



PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

JUERGEN KLEINSCHMIDT

Application No.: 09/574,921

Filed: May 19, 2000

For: REDUCTION OF LASER SPECKLE IN  
PHOTOLITHOGRAPHY BY  
CONTROLLED DISRUPTION OF  
SPATIAL COHERENCE OF LASER  
BEAM

Group Art Unit: Unknown

Examiner: Unknown

**CHANGE OF ATTORNEY OR AGENT'S  
ADDRESS IN APPLICATION  
(37 CFR 1.8(a))**

353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
(415) 772-4900

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited  
with the United States Postal Service as First Class Mail in an  
envelope, addressed to: Commissioner for Patents, P.O.  
Box 1450 Alexandria, VA 22313-1450 on May 11, 2004.  
STALLMAN & POLLOCK LLP

Dated: 05/11/04

By: 

Tanisha Lawrence-Caceres

Sir:

Please send all correspondence for this application to:

STALLMAN & POLLOCK LLP  
Attn: Brian J. Keating  
353 Sacramento Street, Suite 2200  
San Francisco, CA 94111

Please direct all telephone calls to:

Brian J. Keating  
Telephone: (415) 772-4900  
Facsimile: (415) 398-2890

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: 5/11/04

By: 

Michael A. Stallman  
Reg. No. 29,444

Attorneys for Applicant(s)